



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of : **Confirmation No. 2337**
Hiroshi TAKENO : Attorney Docket No. 2004_1129A
Serial No. 10/501,672 : Group Art Unit 1722
Filed July 16, 2004 : Examiner Felisa C. Hiteshew
SILICON EPITAXIAL WAFER AND : **Mail Stop: Amendment**
PROCESS FOR MANUFACTURING
THE SAME

AMENDMENT

THE COMMISSIONER IS AUTHORIZED
TO CHARGE ANY DEFICIENCY IN THE
FEE FOR THIS PAPER TO DEPOSIT
ACCOUNT NO. 23-0975.

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Responsive to the Official Action dated July 27, 2006, the time for responding thereto being extended for three months in accordance with a petition for extension submitted concurrently herewith, please amend the above-identified application as follows: